



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

**SHIRATA, Yosuke**

Serial No.: **09/684,898**

Filed: **October 10, 2000**

For. **LITHOGRAPHY SYSTEM AND METHOD**

**PETITION FOR EXTENSION OF TIME**

Commissioner for Patents  
Washington, D.C. 20231

Group Art Unit: **2851**

Examiner: **NGUYEN, H.**

Confirmation No. **2242**

Date: September 19, 2002

Sir:

Applicant petitions the Commissioner for Patents to extend the time for response to the Office Action dated March 19, 2002 for three months from June 19, 2002 to September 19, 2002.

Attached please find a check in the amount of \$920 to cover the cost of the extension for a large entity. In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 01-2340. Two copies of this paper are enclosed herewith.

Respectfully submitted,

**ARMSTRONG, WESTERMAN & HATTORI, LLP**

*Sadao Kinashi*

Sadao Kinashi  
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